

<b>Notice of References Cited</b>	Application/Control No. 10/705,508		Applicant(s)/Patent Under Reexamination CHENG ET AL.	
	Examiner Adam C. Rehm		Art Unit 2875	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,875,456	04-1975	Kano et al.	313/501
	B	US-5,847,507	12-1998	Butterworth et al.	313/512
	C	US-5,813,753	09-1998	Vriens et al.	362/293
	D	US-5,959,316	09-1999	Lowery, Christopher Haydn	257/98
	E	US-6,501,102	12-2002	Mueller-Mach et al.	257/84
	F	US-6,576,930	06-2003	Reeh et al.	257/98
	G	US-2002/0080501	06-2002	Kawae et al.	359/799
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP2003-249693	09-2003	JP	SHIGEKAZU	H01L 33/00
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Translation of JP2003-249693
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.